Docket No.:

5916/FET/FET/DV

PATENT/OFFICIAL

19/25/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In a Application of

Young Joseph PAIK

Serial No. 09/998,384

Group Art Unit: 28

2812

Filed Ovember 30, 2001

Examiner:

FOR FEEDFORWARD AND FEEDBACK CONTROL FOR CONDITIONING OF CHEMICAL MECHANICAL POLISHING PAD

SURPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

This submission does not constitute a representation that a search has been made or that no better art exists and does not constitute an admission or representation that any of the listed documents is material or constitutes prior art. If it should be determined that any of the listed documents does not constitute prior art under the United States law, Applicants reserve the right

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to present to the Office the relevant facts and law regarding the appropriate status of such document.

No certification or fee is believed to be required. However, the Commissioner is hereby authorized to charge any additional fees should any be required for this submission, or credit any overpayment to deposit account no. 08-0219.

Respectfully submitted,

HALE AND DORR LLP

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Date: 9/19/02

SERIAL NO. ATTY. DOCKET NO. 09/998,384 5916/FET/FET/DV INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449) APPLICANT Young Joseph PAIK GROUP FILING DATE November 30, 2001 2812 U.S. PATENT DOCUMENTS FILING DATE **EXAMINER'S** DATE NAME **CLASS SUBCLASS** PATENT NO. **INITIALS** 05/17/85 10/06/87 Entwistle et al. 4,698,766 07/06/89 10/30/90 Lane et al. 4,967,381 07/20/90 5,208,765 05/04/93 Turnbull 01/29/91 5,226,118 07/06/93 Baker et al. Kobayashi et al. 06/20/90 5,231,585 07/27/93 12/23/93 Weling et al. 5,420,796 05/30/95 06/06/94 Moyne 5,469,361 11/21/95 12/20/94 5,525,808 06/11/96 Irie et al. 02/27/95 12/17/96 Hirsch et al. 5,586,039 11/28/95 Trombetta et al. 02/18/97 5,603,707 09/04/96 09/09/97 Renteln 5,664,987 08/12/97 09/22/98 Sato et al. 5,812,407 10/27/98 06/12/96 Hagi et al. 5,828,778 06/14/96 5,832,224 11/03/98 Fehskens et al. FOREIGN PATENT DOCUMENTS CLASS SUBCLASS EXAMINER'S PATENT NO. DATE COUNTRY Translation INITIALS Yes X 61-171147 08/01/86 Japan X 07/05/94 6-184434 Japan $\overline{\mathbf{X}}$ 10/26/94 0 621 522 A2 Europe \mathbf{X} 8-50161 02/20/96 Japan \mathbf{X} 8-304023 11/22/96 Japan OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) February 1984. "Method and Apparatus of in Situ Measurement and Overlay Error Analysis for Correcting Step and Repeat Lithographic Cameras." IBM Technical Disclosure Bulletin, pp. 4855-4859. October 1984. "Method to Characterize the Stability of a Step and Repeat Lithographic System." IBM Technical Disclosure Bulletin, pp. 2857-2860. **DATE CONSIDERED EXAMINER**

| | | | | | | SHEET <u>2</u> (| <u> </u> | | |
|--------------------------------------|---|---|--|----------------------|-----------------|--|--------------|--|--|
| | | | | ATTY. DOCKET NO | | SERIAL NO. | | | |
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| EXAMINER'S INITIALS | PATENT NO. | DATE | NAME | | CLASS | SUBCLASS | FILING | J.DATI T) | |
| | 5,859,964 | 01/12/99 | Wang et al. | | | | 10/25 | /96 | |
| | 5,863,807 | 01/26/99 | Jang et al. | | | | 03/15/96 | | |
| | 5,870,306 | 02/09/99 | Harada | | | | 06/13 | /97 | |
| | 5,903,455 | 05/11/99 | Sharpe, Jr. et al. | | | | 12/12 | /96 | |
| | 5,916,016 | 06/29/99 | Bothra | | | | 10/23 | /97 | |
| | 5,923,553 | 07/13/99 | Yi | | | | 10/05 | /96 | |
| | 5,930,138 | 07/27/99 | Lin et al. | | | | 09/10 | /97 | |
| <u>-</u> | 5,940,300 | 08/17/99 | Ozaki | | | | 05/08 | /97 | |
| | 5,960,214 | 09/28/99 | Sharpe, Jr. et al. | | | | 12/04 | /96 | |
| | 5,963,881 | 10/05/99 | Kahn et al. | | | | 10/20 | /97 | |
| <u>.</u> | 5,982,920 | 11/09/99 | Tobin, Jr. et al. | | | 01/08 | /97 | | |
| | 6,041,270 | 03/21/00 | Steffan et al. | | | | 12/05 | /97 | |
| | 6,078,845 | 06/20/00 | Friedman | | | - | 11/25 | /96 | |
| | 6,112,130 | 08/29/00 | Fukuda et al. | | | 1 | | 10/01/97 | |
| | 6,148,246 | 11/14/00 | Kawazome | | | | 06/10 | /98 | |
| | | FOR | REIGN PATENT | DOCUMENTS | | | | | |
| EXAMINER'S | PATENT NO. | DATE | to a constitue de la constitue | COUNTRY CLASS | | SUBCLASS | Translation | | |
| INITIALS | | | | | | | Yes | No | |
| | 0 747 795 A2 | 12/11/96 | Europe | | | | X | + | |
| | 10-173029 | 06/26/98 | Japan | | | | + | $\frac{1}{X}$ | |
| | 0 895 145 A1 | 02/03/99 | Europe | | | | X | | |
| | 11-126816 | 05/11/99 | Japan | | | - | | X | |
| | L | | | tle, Date, Pertinent | Pages. Ft | | 1 | | |
| | | | | chitecture of a Manu | «Gerggueenenees | | Design | ed" d | |
| | Patterns." Austi | | | omicotate of a manu | | | | | |
| | Baliga, John. July 1999. "Advanced Process Control: Soon to be a Must." Cahners Semiconductor International. www.semiconductor.net/semiconductor/issues/issues/1999/jul99/docs/feature1.asp | | | | | | | | |
| EXAMINER | | | | ATE CONSIDERED | | | | | |

| INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449) SEP 1 9 2002 | | | | ATTY. DOCKET NO. 5916/FET/FET/DV APPLICANT Young Joseph PAIK FILING DATE November 30, 2001 | | SERIAL NO. 09/998,384 GROUP- 2812 | | | |
|---|-------------|---------------|------------------|--|----------|--|-----------|--------|--|
| | | | J.S. PATENT D | OCUMENTS | | | I ru nic | | |
| EXAMINER'S INITIALS | PATENT NO. | DATE | | NAME CLASS SUBCL | | SUBCLASS | FILING | : | |
| | 6,175,777 | 01/16/01 | Kim | | | : | .01/16/98 | | |
| | 6,178,390 | 01/23/01 | Jun | | | | 09/08/9 | 98 | |
| | 6,185,324 | 02/06/01 | Ishihara et al. | | | | 01/31/95 | | |
| | 6,192,291 | 02/20/01 | Kwon | Kwon | | | 10/08/98 | | |
| | 6,197,604 | 03/06/01 | Miller et al. | | | | 10/01/98 | | |
| | 6,211,094 | 04/03/01 | Jun et al. | Jun et al. | | | 08/23/99 | | |
| | 6,226,792 | 05/01/01 | Goiffon et al. | | | | 10/14/98 | | |
| | 6,230,069 | 05/08/01 | Campbell et al. | | | | 06/26/98 | | |
| | 6,236,903 | 05/22/01 | Kim et al. | | | | 09/25/98 | | |
| | 6,240,330 | 05/29/01 | Kurtzberg et al. | | | | 05/28/97 | | |
| | | FOR | EIGN PATEN | T DOCUMENTS | | | | | |
| EXAMINER'S INITIALS | PATENT NO. | DATE | COUNTRY CLASS | | | SUBCLASS | Trans | lation | |
| | 11-135601 | 05/21/99 | Japan | | | | | X | |
| | WO 00/05759 | 02/03/00 | wo | | | | X | | |
| | WO 00/35063 | 06/15/00 | wo | | | | X | | |
| | ОТН | ER ART (Inclu | ıding Author, T | Title, Date, Pertinent | Pages, E | tc.) | <u> </u> | | |
| July 5, 2001. "Motorola and Advanced Micro Devices Buy ObjectSpace Catalyst Advanced Process Control Product for Five Wafer Fabs." Semiconductor FABTECH. www.semiconductorfabtech.com/industry.news/9907/20.07.shtml October 15, 2001. Search Report prepared by the Austrian Patent Office for Singapore Patent Application No. 200004286-1. Johnson, Bob. June 10, 2002. "Advanced Process Control Key to Moore's Law." Gartner, Inc. July 9, 2002. International Search Report prepared by the European Patent Office for PCT/US01/24910. July 29, 2002. International Search Report prepared by the European Patent Office for PCT/US01/27407. Sendermen Thomas 2002. "APC as a Compatitive Manufacturing Technology: AMD's Vision for 300mm." | | | | | | | | | |
| Sonderman, Thomas. 2002. "APC as a Competitive Manufacturing Technology: AMD's Vision for 300mm." AEC/APC. | | | | | | | | | |
| EXAMINER | | | | OATE CONSIDERED |) | | | | |

| INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449) | | | | ATTY. DOCKET NO. 5916/FET/FET/DV | | SERIAL NO. 09/998,384 | | | |
|--|----------------|-------------|--------------------------------------|-------------------------------------|---------------|--|----------------------|-----------------|--|
| | | | | APPLICANT Young Joseph PAIK | | | | | |
| | | | | FILING DATE November 30, 2001 | | GROUP 2812 | | | |
| | W.127 | | U.S. PATENT D | OCUMENTS | | | | | |
| EXAMINER'S INITIALS | PATENT NO. | DATE | 1 | CLASS | SUBCLASS | FILING DATE | | | |
| | 6,240,331 | 05/29/01 | Yun | | | | 08/18/98 | | |
| | 6,248,602 | 06/19/01 | Bode et al. Taibot et al. Tan et al. | | | | 11/01/99 01/08/99 | | |
| | 6,252,412 | 06/26/01 | | | | | | | |
| | 6,263,255 | 07/17/01 | | | | | 05/18/98 | | |
| | 6,292,708 | 09/18/01 | Allen et al. | Allen et al. | | | 06/11/98 | | |
| - , | 6,298,274 | 10/02/01 | Inoue | Inoue | | | 09/01/99 | | |
| | 6,303,395 | 10/16/01 | Nulman | | | _ | 06/01 | /99 | |
| · · · · | 6,345,315 | 02/05/02 | Mishra | | | | 08/12/98 | | |
| | 6,366,934 | 04/02/02 | Cheng et al. | | | | 06/02 | | |
| EXAMINER'S | PATENT NO. | FO DATE | REIGN PATEN | T DOCUMENTS | S CLASS | SUBCLASS | | | |
| INITIALS | | | | | | | Yes | Inslation No | |
| | WO 00/79355 A1 | 12/28/00 | wo | | | | X | - | |
| | 2001-76982 | 03/23/01 | Japan | | | | | X | |
| | WO 01/33501 A1 | 05/10/01 | WO | | | | X | | |
| | | | | | | | | | |
| | ОТНІ | ER ART (Inc | luding Author, T | litle, Date, Perti | nent Pages, E | fc.) | | | |
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